

Notice of References Cited	Application/Control No. 10/783,227	Applicant(s)/Patent Under Reexamination TAGA ET AL.	
	Examiner David S. Kim	Art Unit 2633	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,822,214 B2	11-2004	Han et al.	250/214R
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	J	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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